

Notice of References Cited	Application/Control No. 10/552,029	Applicant(s)/Patent Under Reexamination CHANG ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0134003	07-2003	Fong et al.	424/773
	B	US-			
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	D	US-			
	E	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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